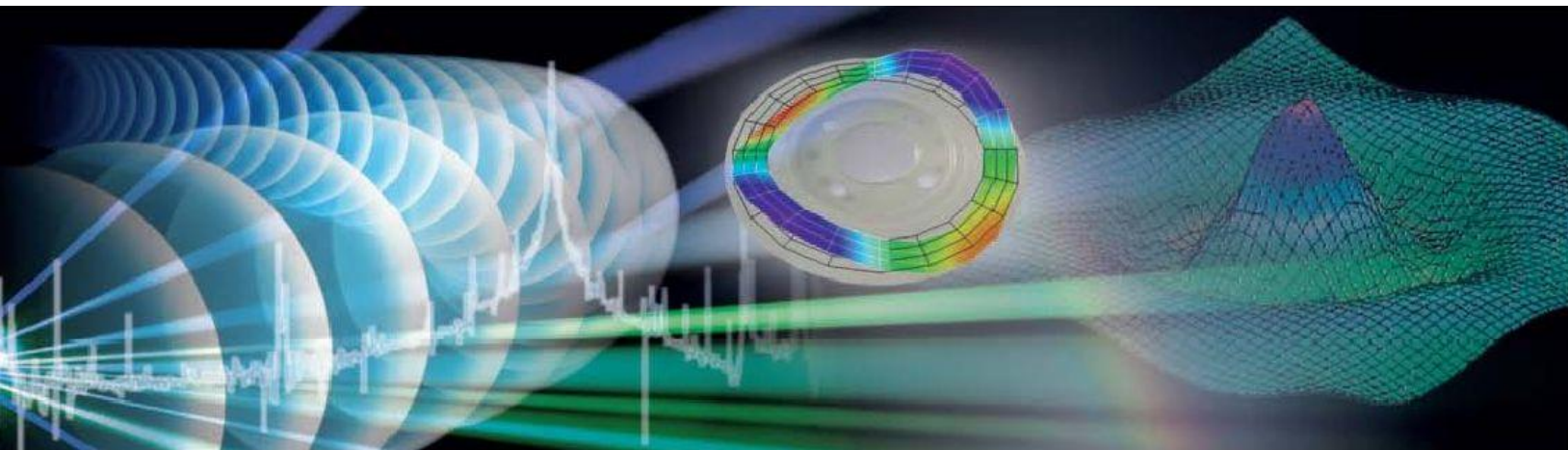


Optical Characterization of Microstructures



Measurement of Ultra-High-Frequency Mechanical Motion up to the GHz Regime

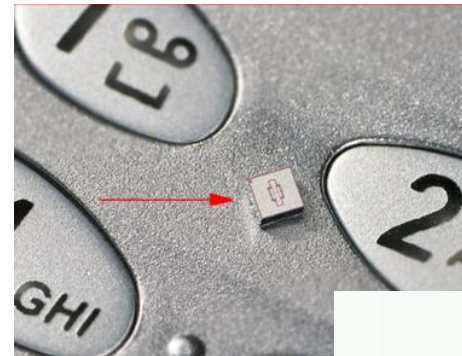
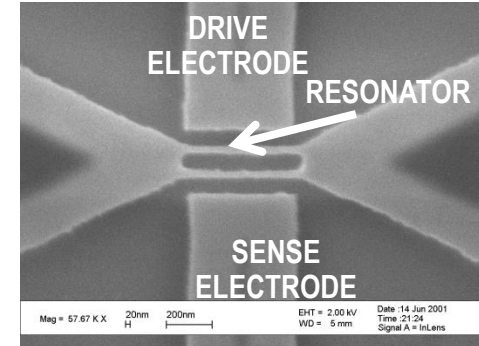
Heinrich Steger, Polytec GmbH

Agenda

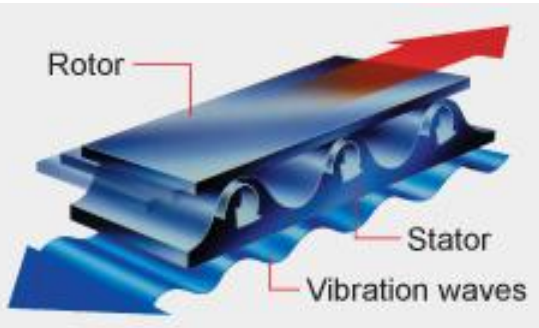
- **Why study UHF mechanical motions?**
 - Application fields
- **Measurement tasks**
 - RF-MEMS
 - SAW filters
 - Ultrasonic transducers
- **UHF Laser-Doppler-Vibrometry**
 - System design
 - Measurement capabilities

Antennas RF MEMS
Color bi-stable display
Micro-switches
Tunable capacitors and inductors
Tunable filters
Directional microphone

NEMS



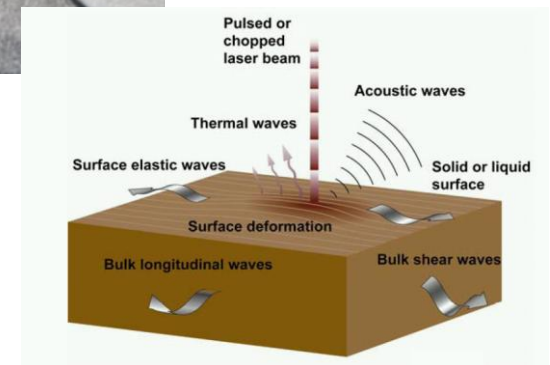
BAW or SAW filters



Ultrasonic motors



Ultrasound Imaging



Laser Ultrasonics

Typical HF applications

- **Crystal Oszillators**

< 250 MHz

- **Ultrasonic Motors**

0.1 MHz – 150 MHz

- **MEMS program.**

- **Clock Oszillators**

1 MHz – 200 MHz

- **Ultrasound Imaging**

10 MHz – 500 MHz

- **Laser Ultrasound and Thin Films**

10 MHz – 500 MHz

- **NEMS**

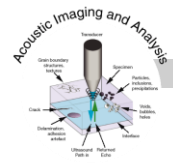
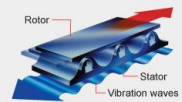
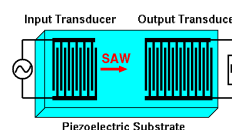
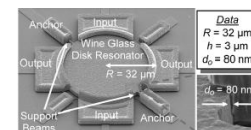
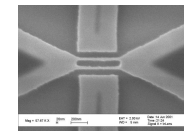
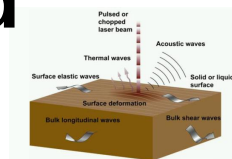
50 MHz – 1 GHz

- **RF – MEMS**

20 MHz – 3 GHz

- **BAW/SAW Filters**

10 MHz - >> 3 GHz



Challenges of HF Motion Measurement

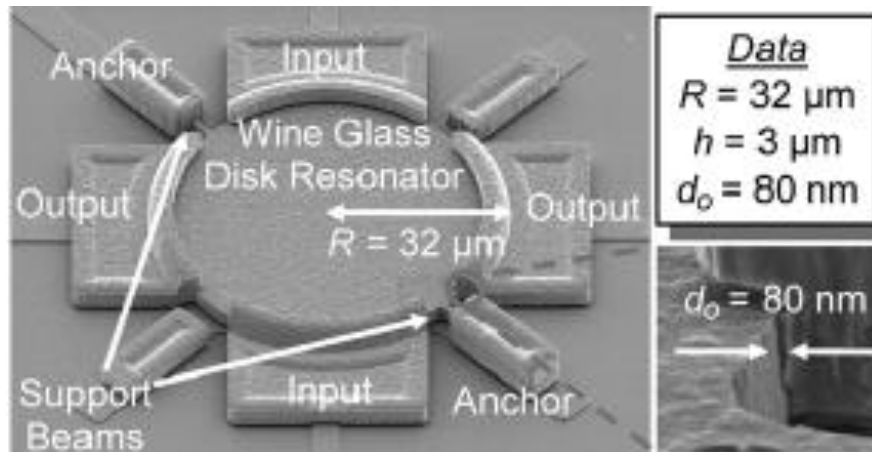
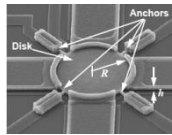
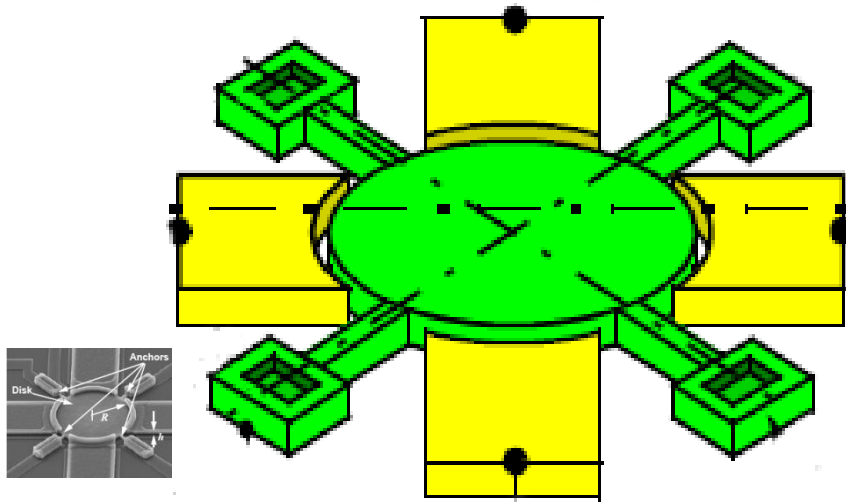
■ Ultra High Frequencies

- High Frequency range \Rightarrow **GHz Vibration sensor**
- HF typically shows up at **small structures** and imply **shorter wavelengths** of acoustical waves, e.g. Wavelength $< 10\mu\text{m}$ \Rightarrow **High lateral resolution**
- Higher Frequencies means **smaller displacements** \Rightarrow **Resolve amplitudes $< \text{pm}$**
- HF means **higher velocities** \Rightarrow **$v > 100 \text{ m/s}$**

RF-MEMS

- **R**adio**F**requency-**M**icro**e**l**e**ctro**M**echanical**S**ystem
 - Electronic components of which moving sub-millimeter-sized parts provide RF functionality
- Various types of RF MEMS components
 - CMOS integrable RF MEMS resonators and self-sustained oscillators with small form factor and low phase noise
 - RF MEMS tunable inductors
 - RF MEMS switches, switched capacitors and varactors

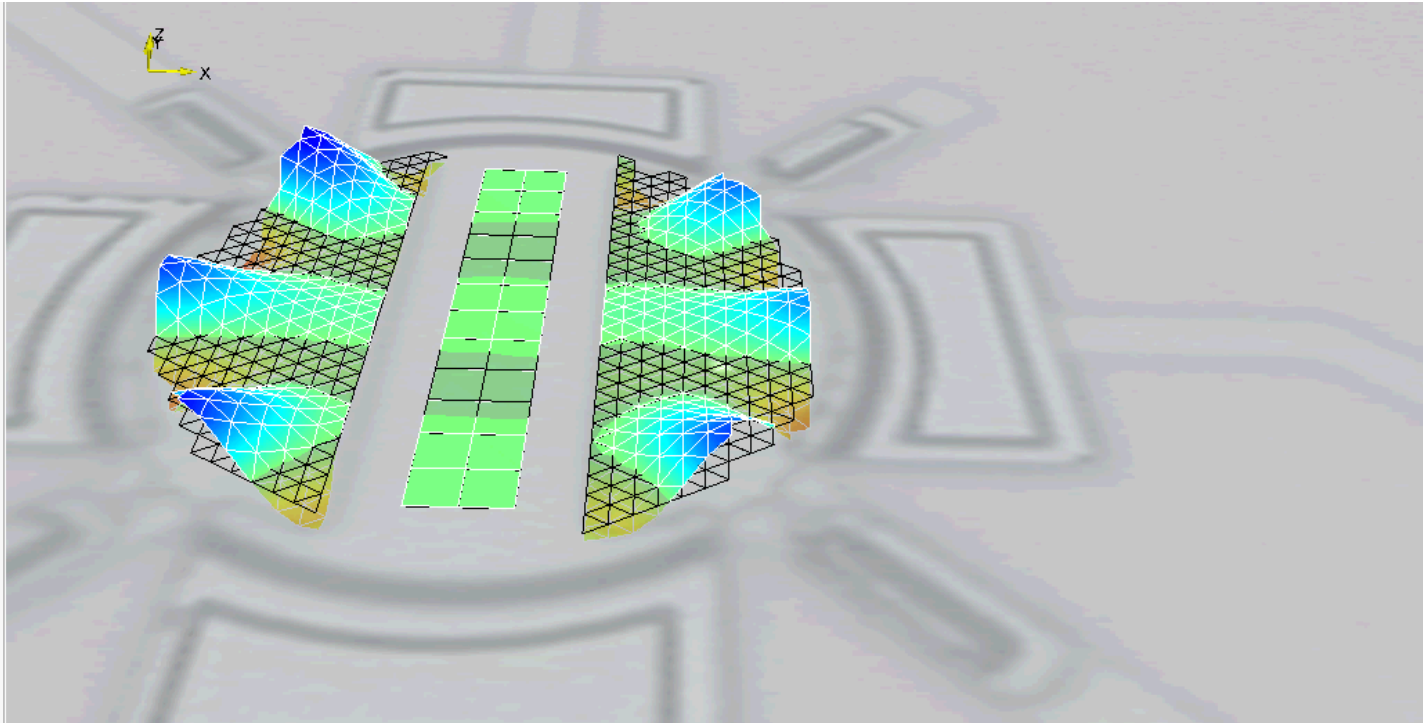
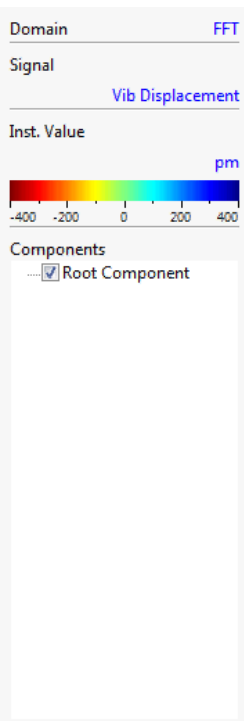
RF-MEMS Resonator



Courtesy Dr. Clark Nguyen, BSAC

- **Vibrating Micro Mechanical Resonator**
- Designed for use as on-chip **high-Q resonators** used in wireless communication systems for **frequency generation and filtering.**
- Utilizes a **wine-glass resonant mode** at 61.13 MHz
- **High Q factor** (>10,000 in air)

RF-MEMS Resonator

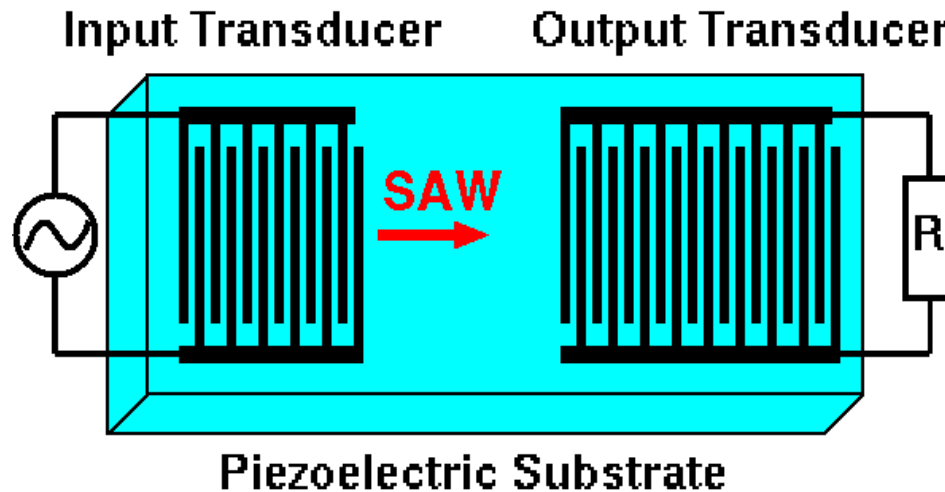


Band 1	85.35156 MHz
Angle	10 °
Direction	+ Z

Courtesy Dr. Clark Nguyen, BSAC

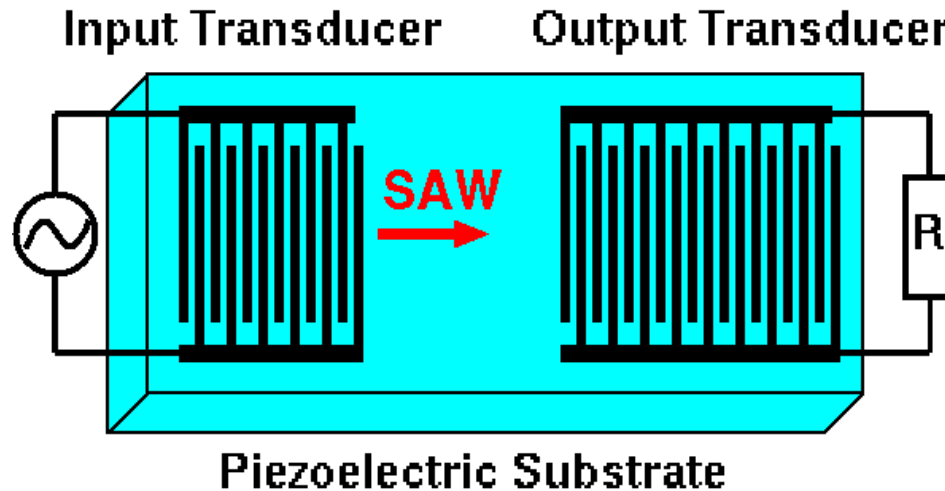
- Scan measurement of higher frequency mode at 85.35 MHz

Surface Acoustic Wave Filter



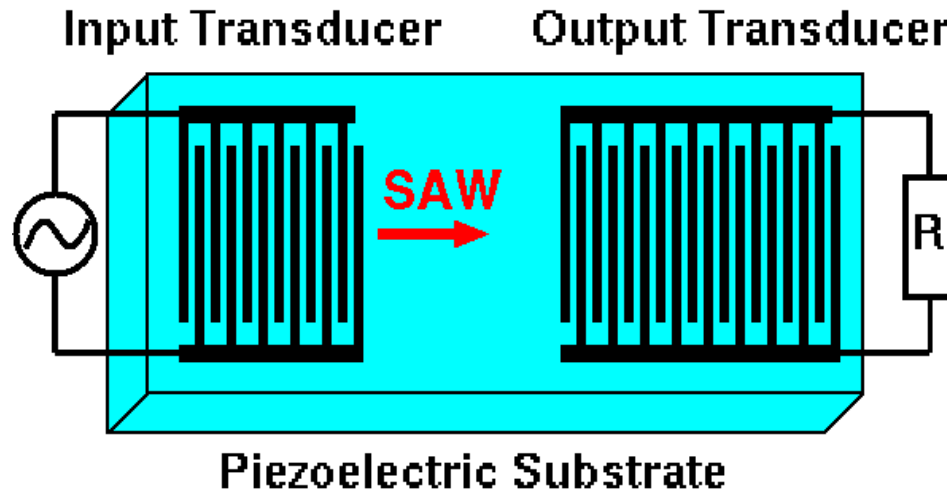
- SAW devices are used as filters, oscillators and transformers, devices that are based on the transduction of acoustic waves.
- The transduction from electric energy to mechanical energy (in the form of SAWs) is accomplished by the use of piezoelectric materials.

Surface Acoustic Wave Filter



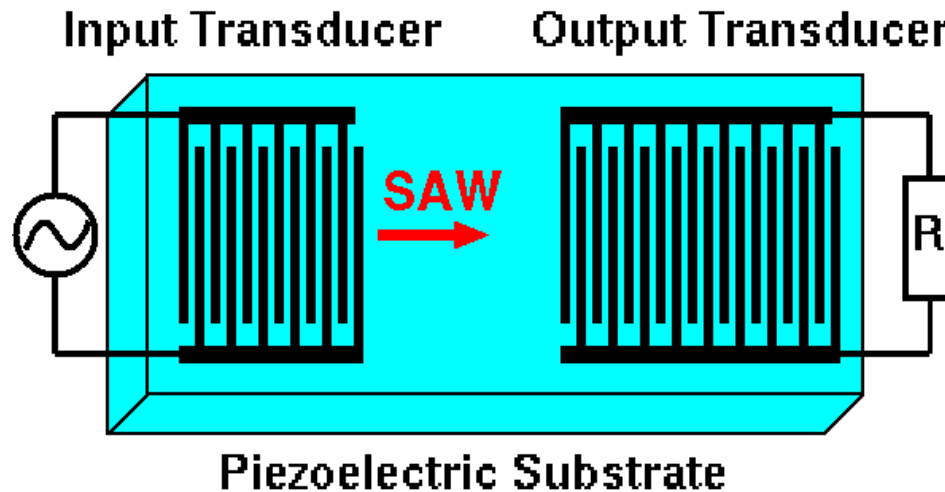
- SAW filters are used e.g. in mobile phones, and provide **significant advantages** in
 - performance,
 - cost, and
 - size

Surface Acoustic Wave Filter



- HF Bandpass filter for electrical signals < 3 GHz
- Low transmission bandwidth
- Applications
 - HF transmitter and receiver: e.g. ISM, WLAN, GSM, ...
 - Intermediate frequency filter in mobile phones etc.

Surface Acoustic Wave Filter



■ Electrical input

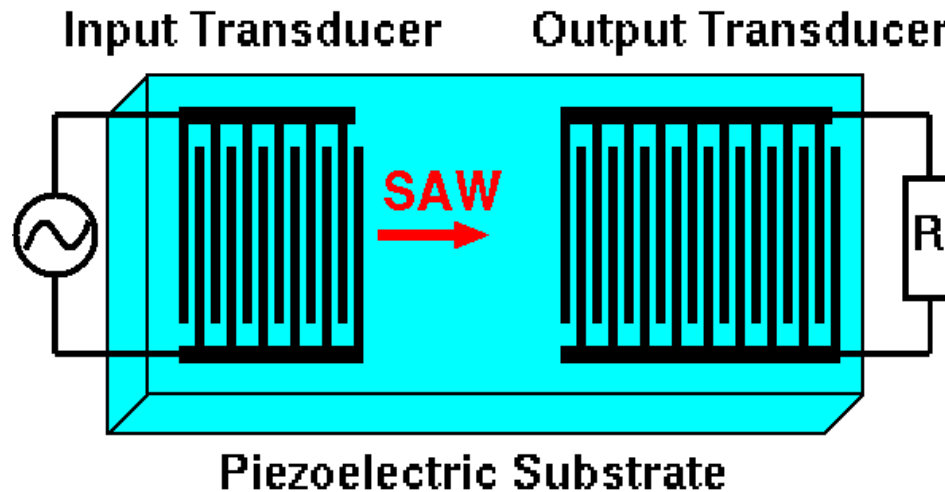
=> Conversion in **S**urface **A**coustical **W**ave

=> Filtering with specific characteristic

=> Conversion in electrical Output signal

■ Specific electrical output

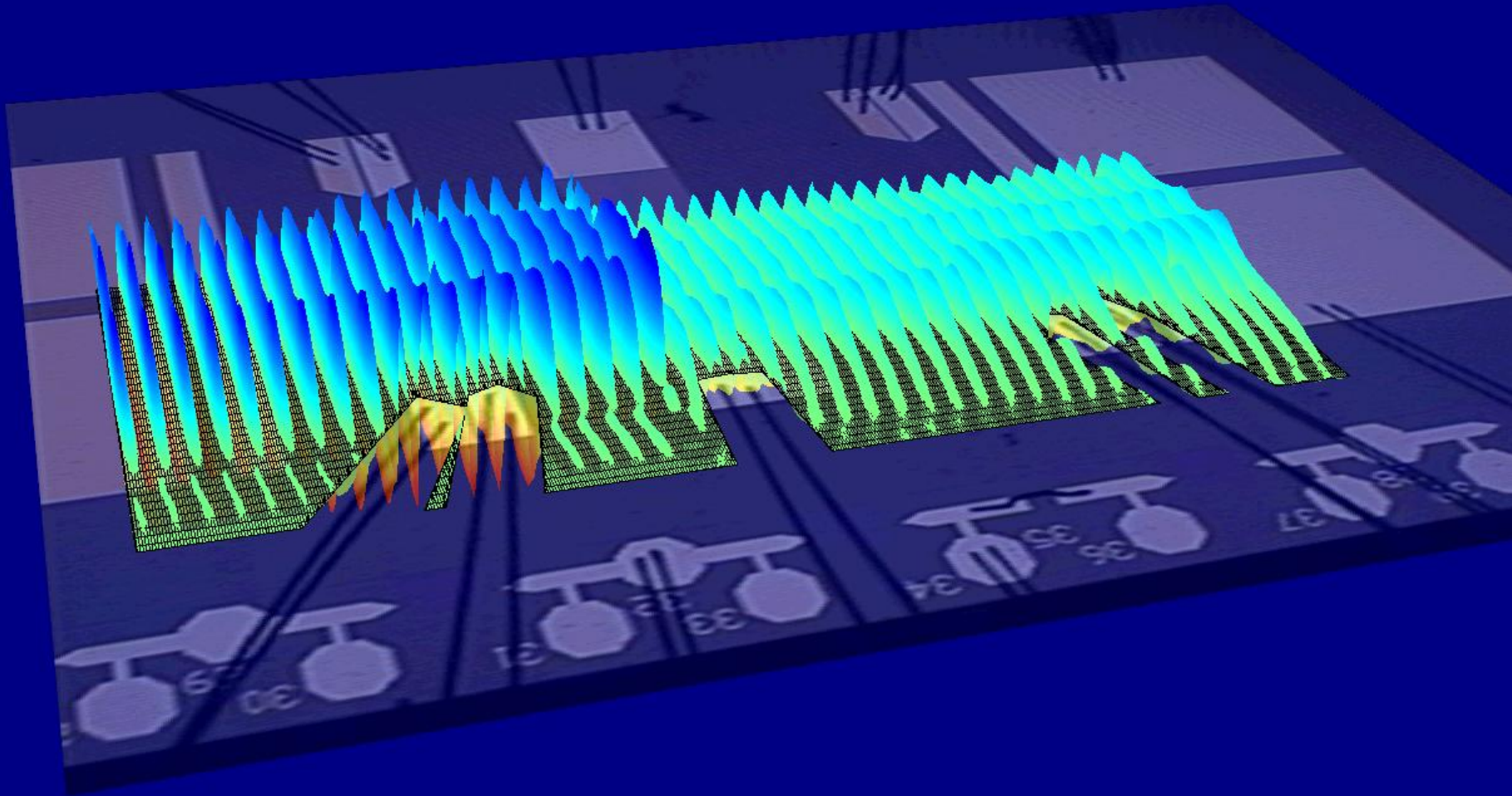
Surface Acoustic Wave Filter



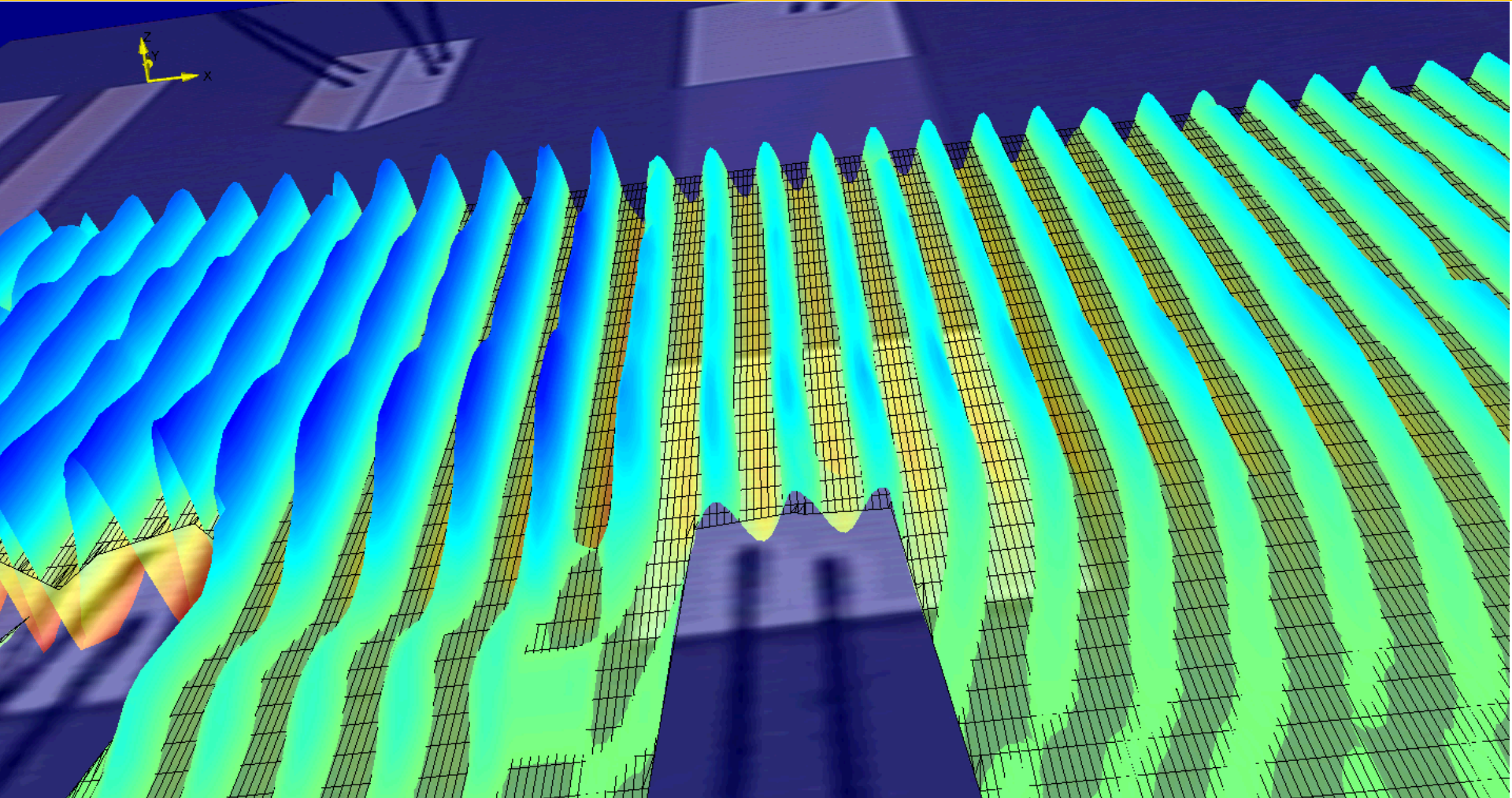
■ Challenges for Measurement:

- Very high frequency \Rightarrow **High measurement bandwidth**
- High Q value \Rightarrow **High frequency resolution**
- Short acoustical wavelengths \Rightarrow **High lateral resolution**
- Small displacements \Rightarrow **Low noise**

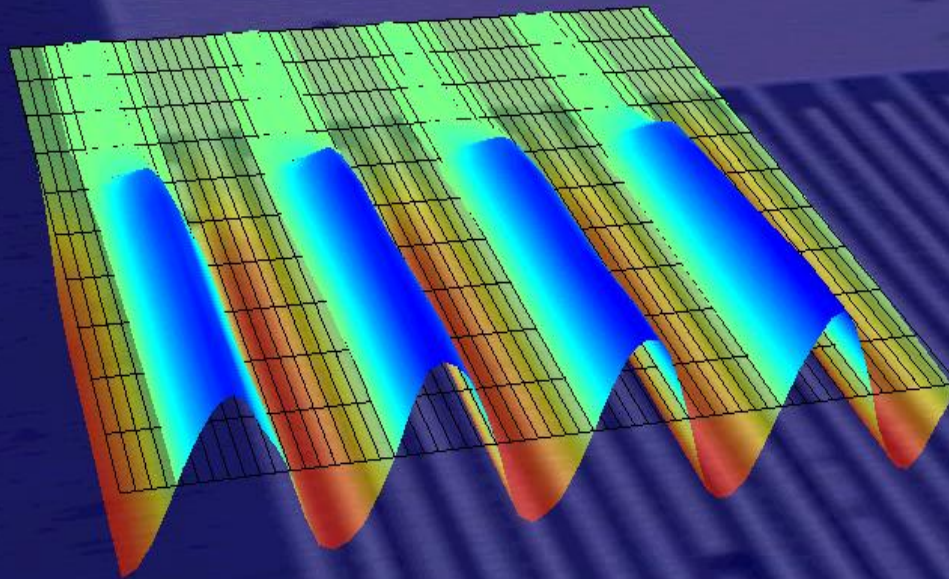
Surface Wave Propagation



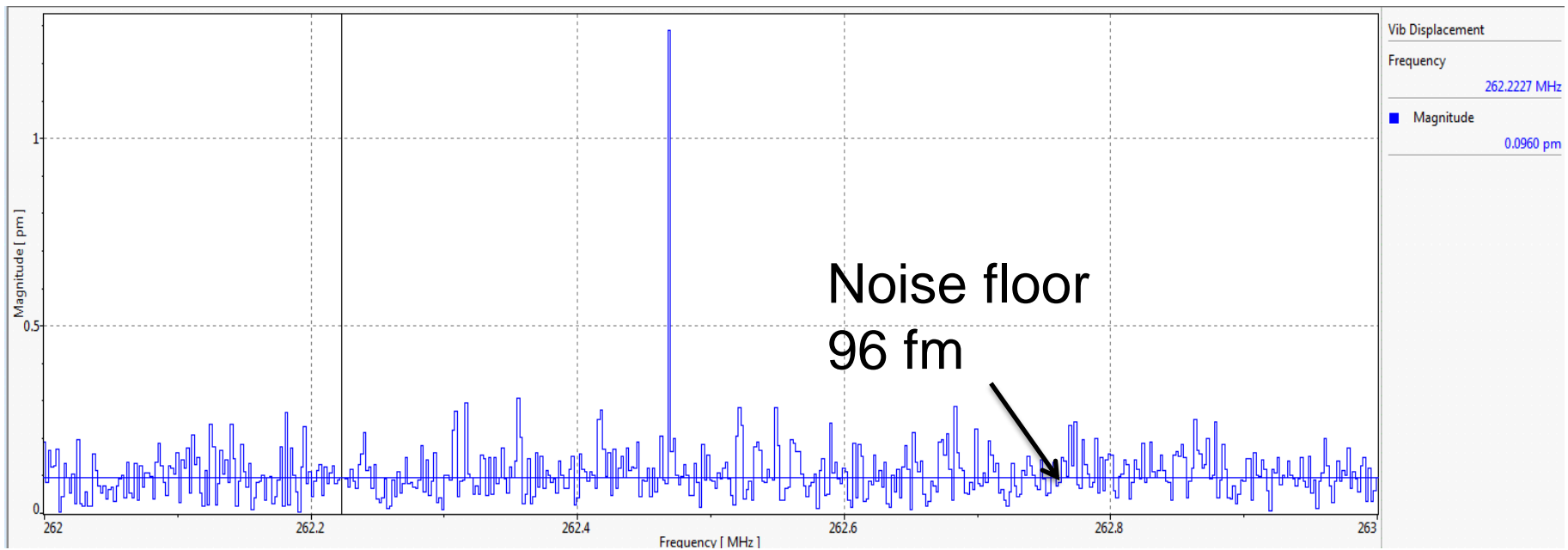
Surface Wave Propagation



Surface Wave Propagation (Detail)



SAW-Filter response after narrowband excitation



Noise floor reduction by complex averaging

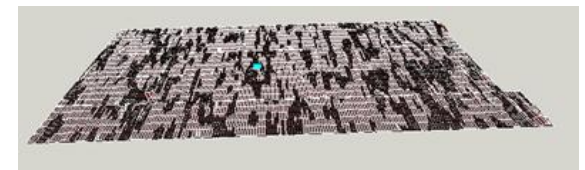
Application: Medical Imaging

- Transducers for ultrasonic frontend devices in medical diagnostics



Application: Medical Imaging

- Abdominal imaging, cellular imaging and measuring surfaces.
- The aim is to determine the 3-dim sound field dispersion in space by measuring the out-of-plane vibration of the components.
- Transducer Array: By selecting the correct amplitude and phase for each array element, it is possible, for example, to generate a focused ultrasonic wave



Ultrasound Transducer Array

Domäne [Zeit](#)

Signal [Usr Zeit / Vib / Weg](#)

Zeitsignal [nm](#)

Komponenten

- Scan
 - kombi1_1_bis_5
 - Root Comp
 - Root Comp
 - Root Comp
 - Root Comp
 - Root Comp
 - kombi_test
 - kombi_1_1_1
 - Root Cc
 - Root Cc
 - Root Cc
 - Root Cc
 - Root Cc
 - kombi_1_1_1
 - Root Cc
 - Root Cc
 - Root Cc



Start 7.11 μs

Aktuell 7.11 μs

Ende 8.88 μs

Schrittweite 1

Frame 1

Index 2388

Zeitsignal 195.3 μm

Status [Gültig](#)

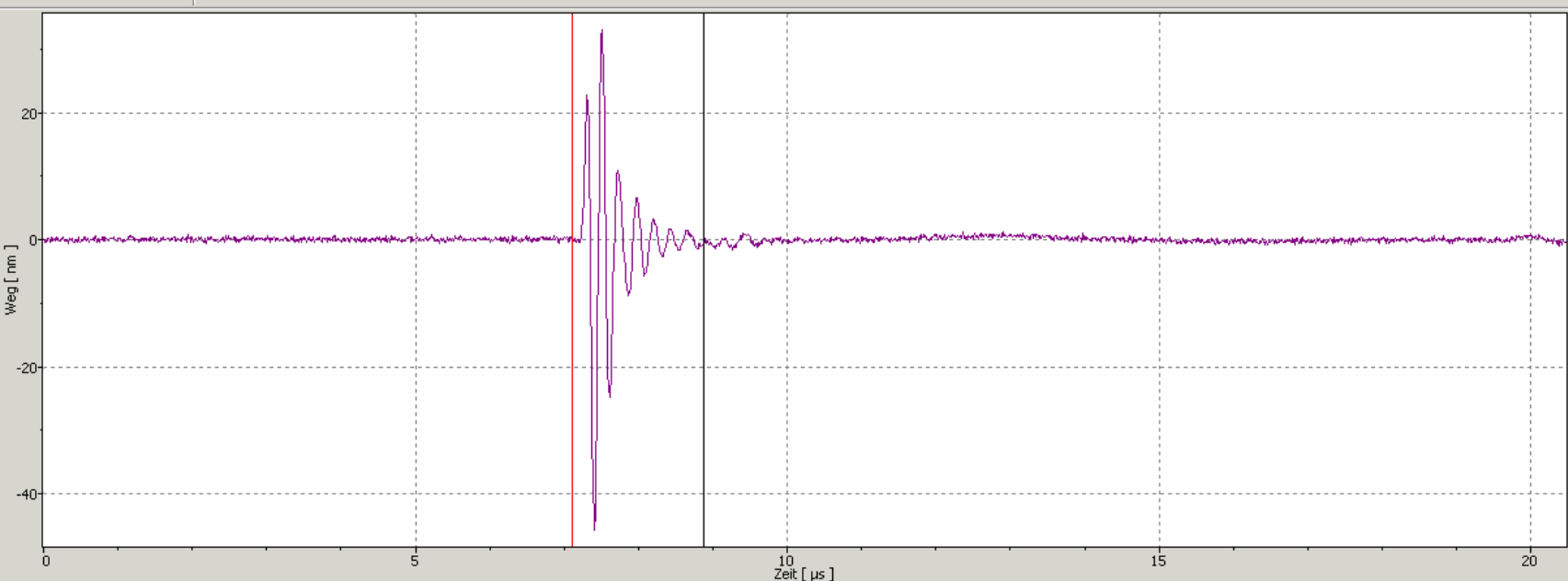
Richtung + Z

3D-Punkt

X: 0.0036 m

Y: 0.0006 m

Z: 0.0000 m



[Usr Zeit / Vib / Weg](#)

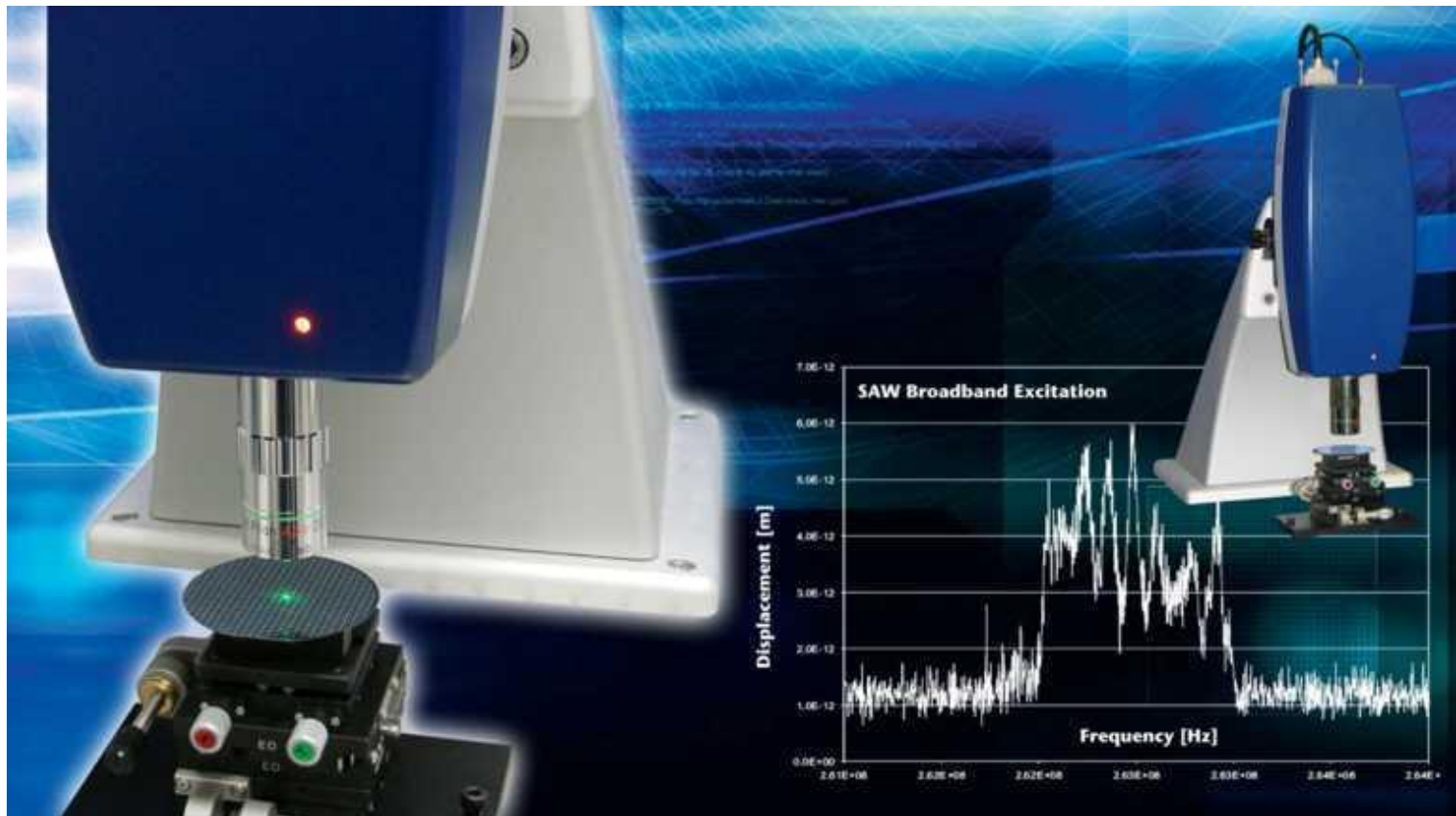
Index 2388

Frame 1

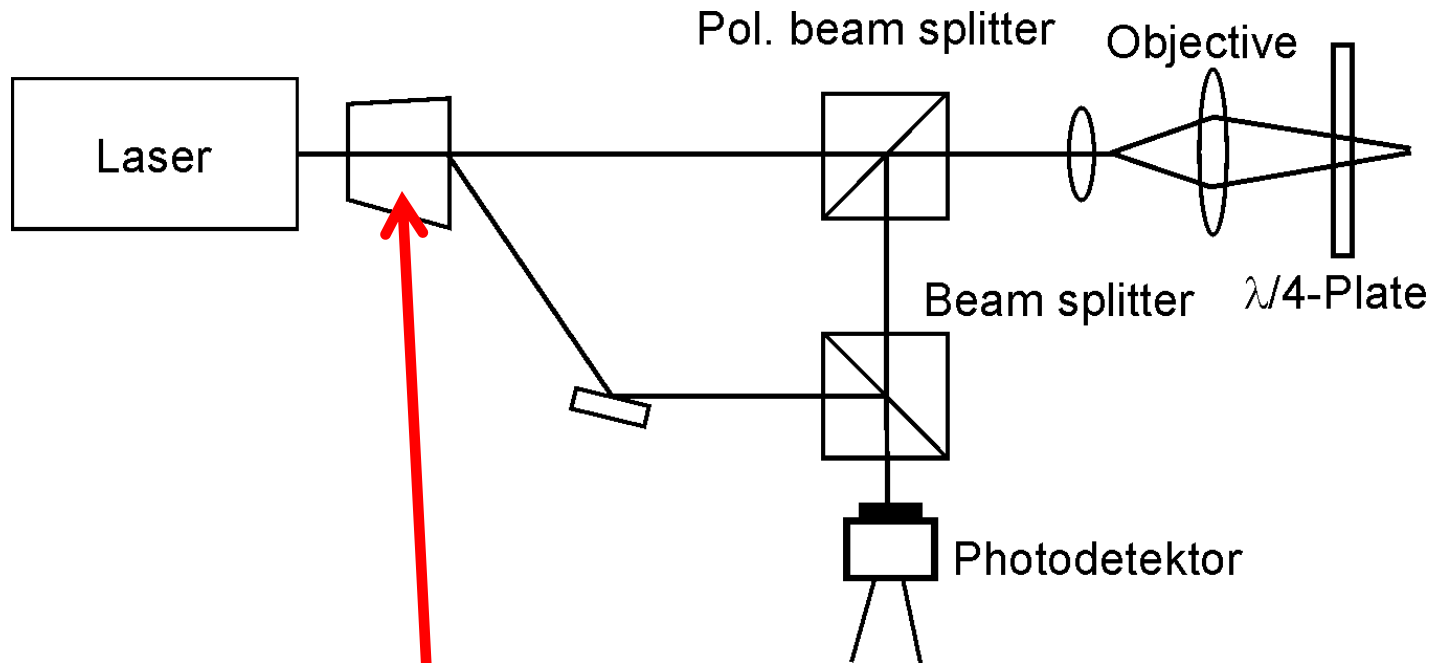
Zeit 7.11 μs

Weg 0.46 nm

The UHF-120-SV Ultra-high Frequency Scanning Vibrometer



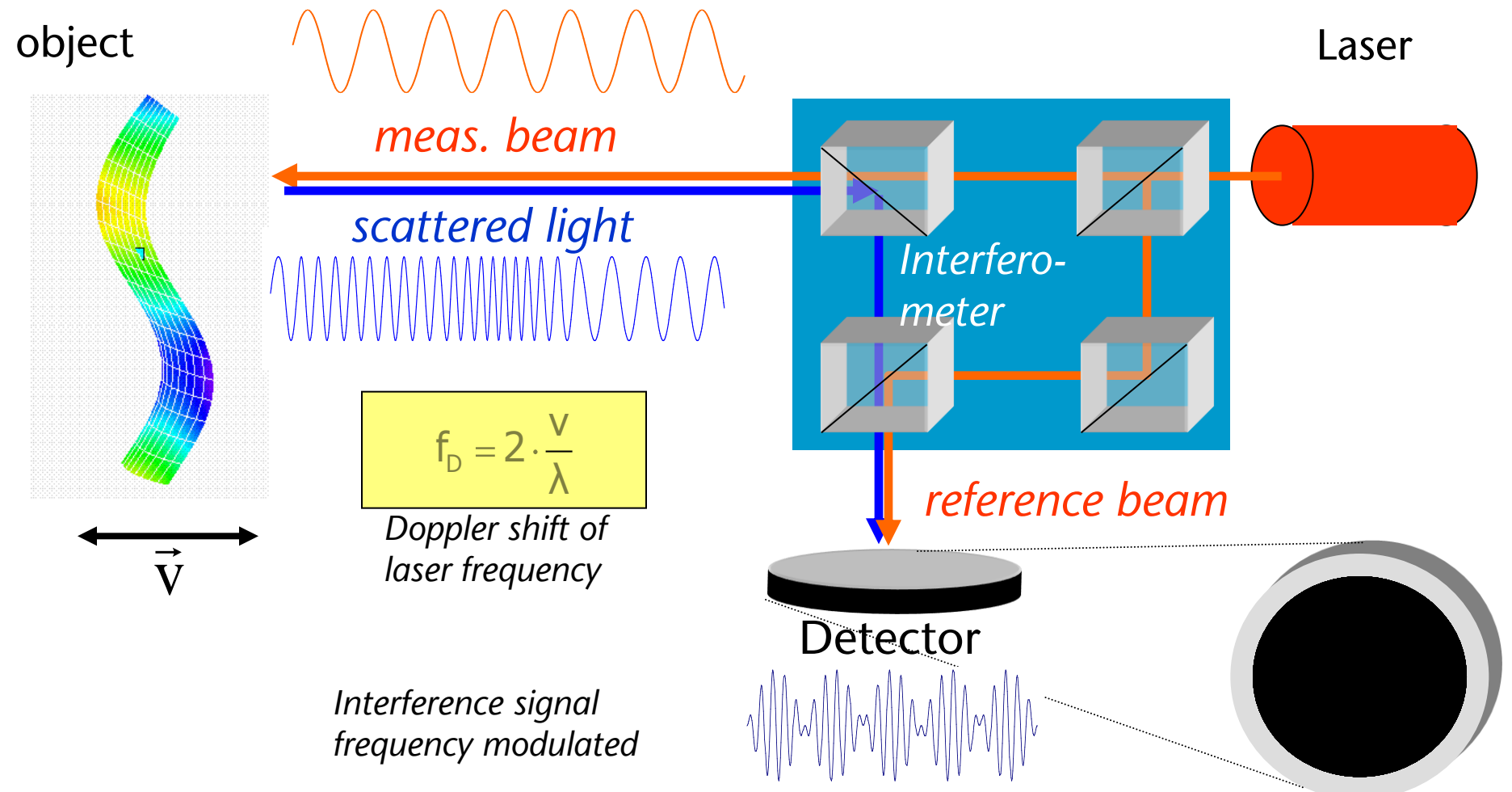
Optical Setup



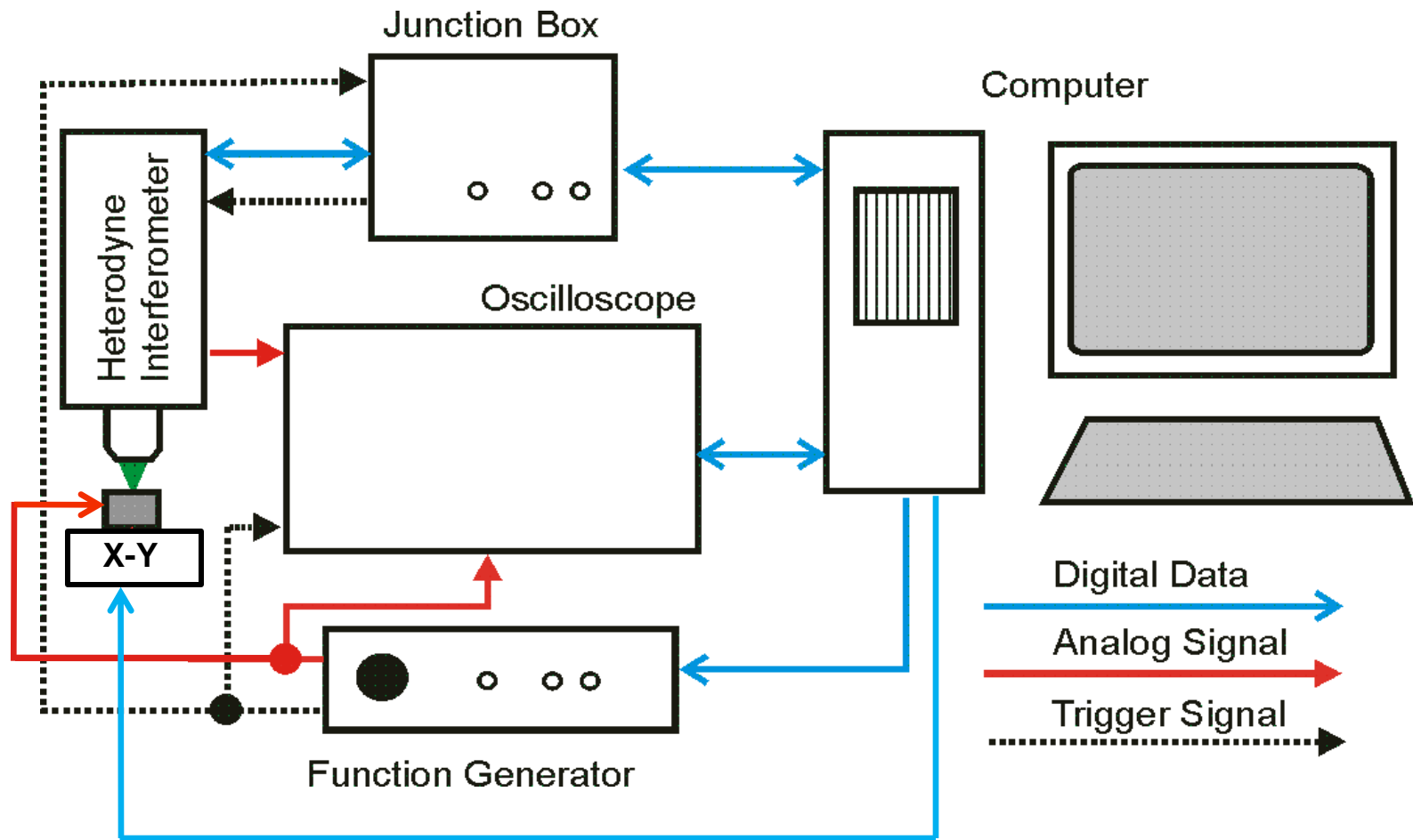
■ Innovations:

- Carrier frequency $f_{\text{carrier}} > 600 \text{ MHz}$
- Signal processing for Measurements up to 1,2 GHz

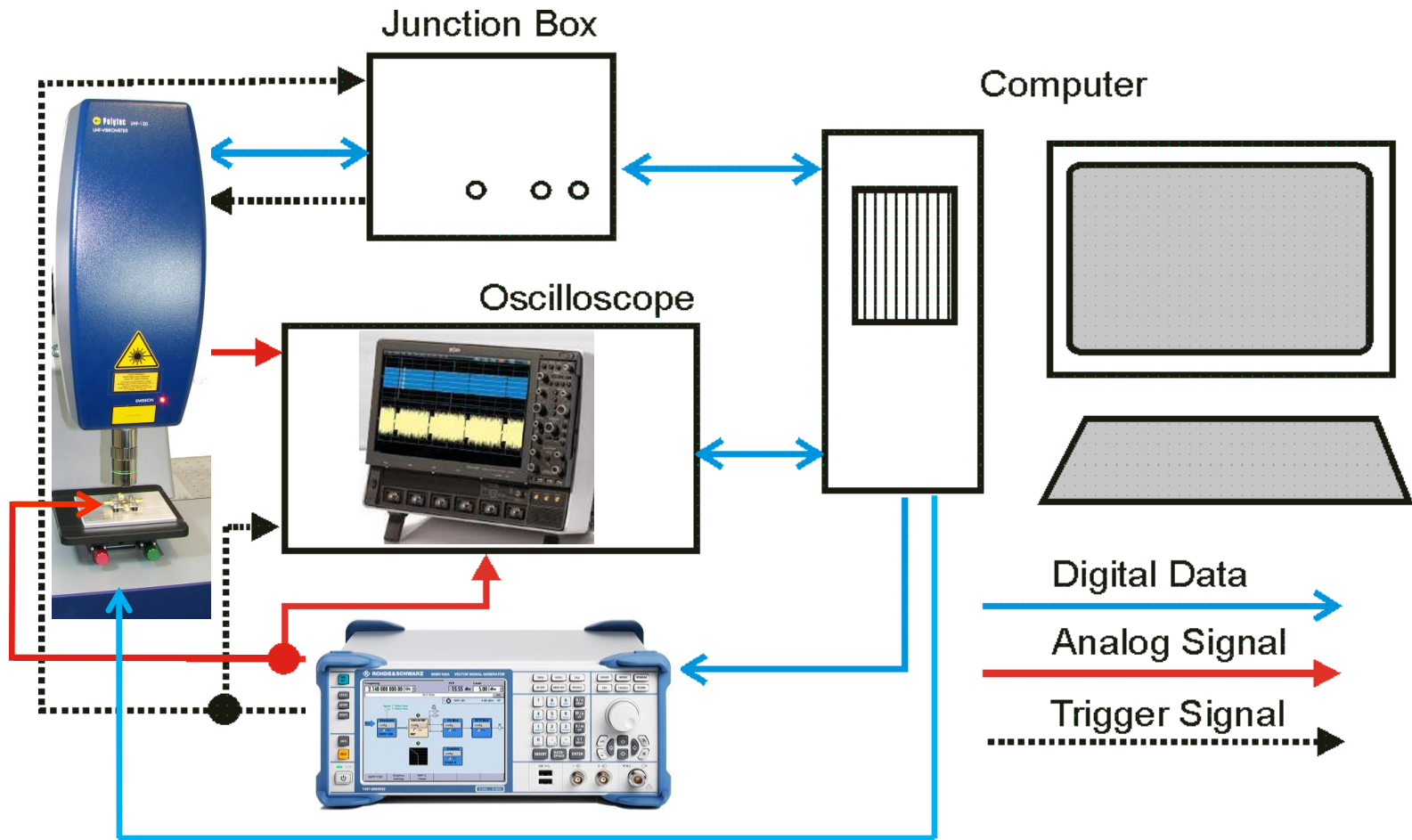
Operation Principle



Components

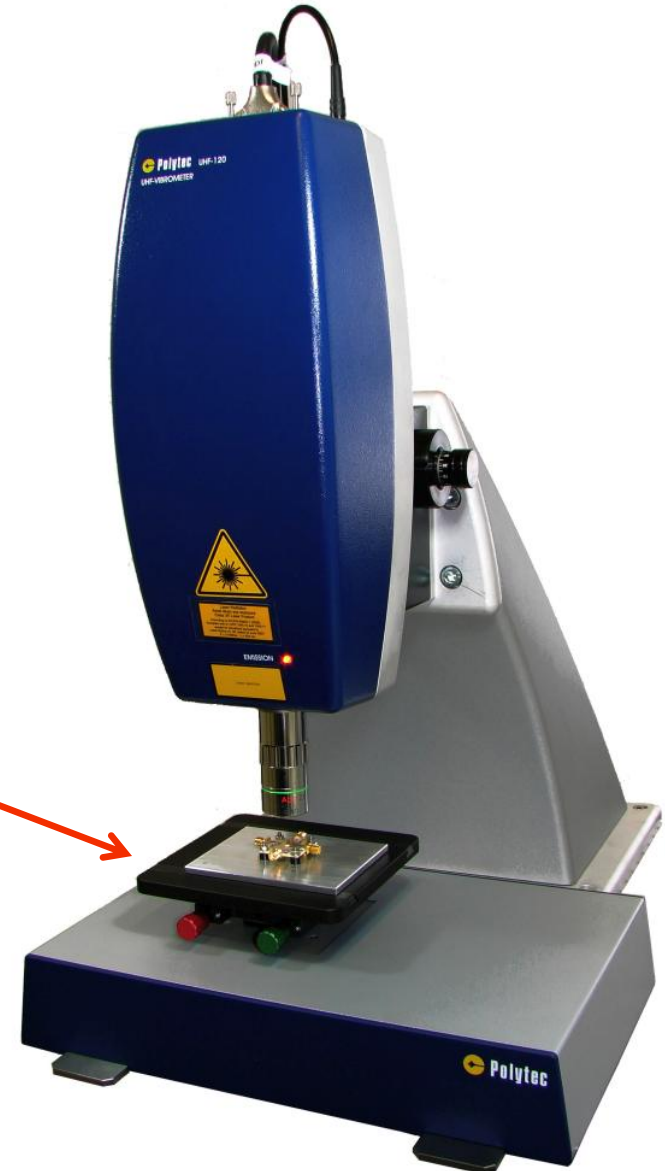


Components



Heterodyne Interferometer and Scanning Hardware

- X-Y Traverse
- Scanning
- Operational deflection shape measurement
- „Slow-Motion“-Visualisation

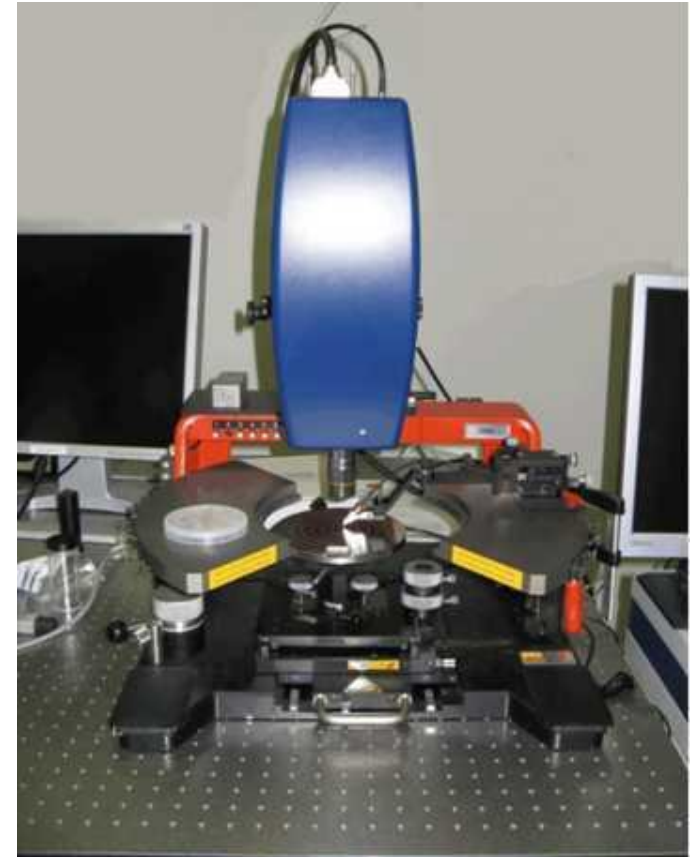


Laser Spot Size

- Speed of sound for silicon $\sim 2.2 \cdot 10^3$ m/s, \Rightarrow acoustical wave length at 1 GHz ~ 2.2 μm .
- \Rightarrow Spot size < 1 μm is realized to enable measurements up to 1.2 GHz at a specific equal deflecting sample point

Integration in probe stations

- For measurements on wafer level
- Simple Integration into a probe station
- Positioning of laser spot with integrated camera
- Automated routine measurements possible



Summary

- **Studying UHFmechanical motion is a subject with increasing importance in many high tech application fields**
- **Precise measurement data are the key to fast prototype characterization and efficient device development**
- **Optical methods like Laser Vibrometry deliver unique measurement capabilities**

Company Portrait

Business Units

Optical Measurement Systems

Photonics

Spectral Analytics



Polytec Headquarters
R&D, Manufacturing & Sales

Polytec England

Polytec Inc.
Hopkinton, MA, USA

Polytec Inc.
Dexter, MI, USA

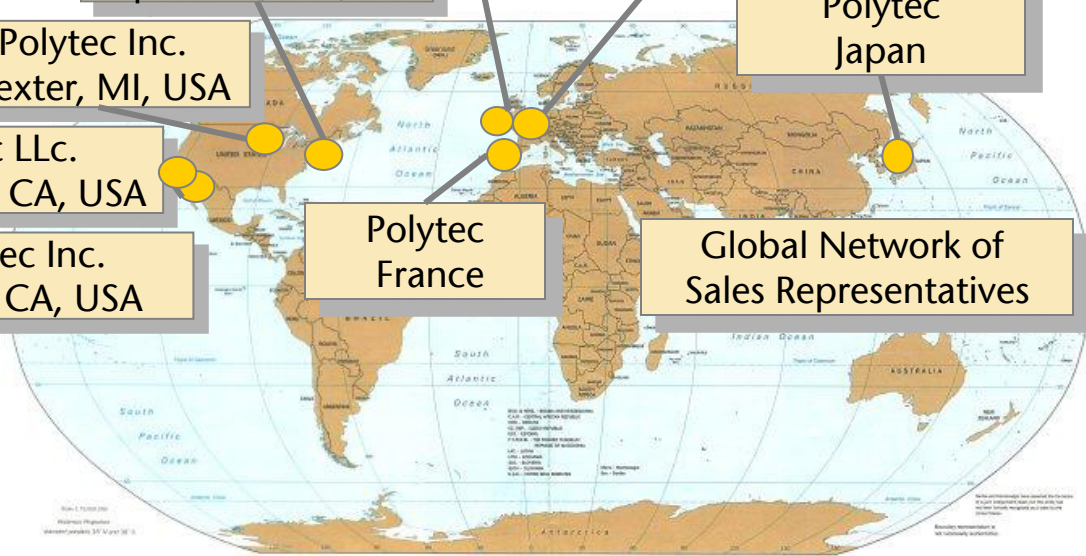
Polytec
Japan

Polytec LLC.
Campbell, CA, USA

Polytec Inc.
Irvine, CA, USA

Polytec
France

Global Network of
Sales Representatives



1967 Foundation

Polytec today

300 EMP worldwide

50 EMP R&D



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